

**PATENT ASSIGNMENT**

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California Institute of Technology	11/04/2010
<b>RECEIVING PARTY DATA</b>	
<b>Name:</b>	National Science Foundation
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<b>PROPERTY NUMBERS Total: 1</b>	
<b>Property Type</b>	<b>Number</b>
<b>Application Number:</b>	12626239
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## License to the United States Government

Invention Title: Method and Apparatus for Controlled Fabrication of Micro and Nanoscale Structures by Thermocapillary Lithography

Inventors: Sandra M. Troian

Patent Application Serial No: 12/626,239

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Foreign Applications filed/intended in (countries):

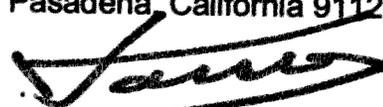
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Fred Farina, Asst VP for Tech Transfer

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